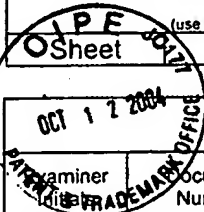


FIRST INFORMATION DISCLOSURE STATEMENT BY APPLICANT

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Sheet 1 of 3

Complete if Known

Application Number	10/715,017
Filing Date	November 17, 2003
First Named Inventor	Arun Majumdar et al.
Examiner Name	LEON YUN BON LUM
Attorney Docket Number	028726-022

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Examiner Initials	Document Number	Kind Code (if known)	Name of Patentee or Applicant of Cited Document	Issue/Publication Date (MM-DD-YYYY)
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					Translation	Partial Translation	Eng. Lang. Summary	Search Report	IPER	Abstract	Cited in Spec
LYL	WO 95/02180		WIPO	01/19/95							
LYL	WO 98/50773		WIPO	11/12/98							

Examiner Signature		Date Considered	7/8/05
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FIRST INFORMATION DISCLOSURE STATEMENT BY APPLICANT

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Sheet 2 of 3

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Application Number	10/715,017
Filing Date	November 17, 2003
First Named Inventor	Arun Majumdar et al.
Examiner Name	LEON YUN BON LUM
Attorney Docket Number	028726-022

NON-PATENT LITERATURE DOCUMENTS


Examiner Initials	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.
LYL	ALBRECHT, T.R., et al., "Microfabrication of cantilever styli for the atomic force microscope," <u>J. Vac. Sci. Technol.</u> , A 8(4), Jul/Aug 1990, pp. 3386-3396
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Examiner Signature	Date Considered	7/8/05
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*EXAMINER: Initial if reference considered, whether or not citation is in conformance with M.P.E.P. § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.

Substitute for form 1449A/PTO & 1449B/PTO			Complete if Known		
FIRST INFORMATION DISCLOSURE STATEMENT BY APPLICANT (use as many sheets as necessary)			Application Number	10/715,017	
			Filing Date	November 17, 2003	
			First Named Inventor	Arun Majumdar et al.	
			Examiner Name	LEON YUN BON LUM	
Sheet	3	of	3	Attorney Docket Number	028726-022

NON-PATENT LITERATURE DOCUMENTS	
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Examiner Signature		Date Considered	7/8/05
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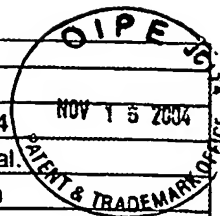
SECOND INFORMATION DISCLOSURE STATEMENT BY APPLICANT

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Sheet 1 of 1

Complete if Known

Application Number 10/715,017
Filing Date November 17, 2004
First Named Inventor Arun Majumdar et al.
Examiner Name Leon Yun Bon Lum
Attorney Docket Number 028726-022



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Examiner Initials	Document Number	Kind Code (if known)	Name of Patentee or Applicant of Cited Document	Issue/Publication Date (MM-DD-YYYY)
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					Translation	Partial Translation	Eng. Lang. Summary	Search Report	IPER	Abstract	Cited In Spec

NON-PATENT LITERATURE DOCUMENTS

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 Filing Date November 17, 2003
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 Examiner Name LEON YUN BON LUM
 Attorney Docket Number 028726-022

U.S. PATENT DOCUMENTS

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					Translation	Partial Translation	Eng. Lang. Summary	Search Report	IPER	Abstract	Cited in Spec

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